

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	((substrate or wafer or semiconductor) and roller\$4 and clamp and edge and suction and vacuum).clm.	US-PGPUB; USPAT; USOCR	OR	ON	2008/10/20 07:14

10/ 20/ 2008 7:50:26 AM

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